



CryogenFree MFM/AFM in Cryogen Free Magnet System

CRYOGEN FREE MFM/AFM

- RIGID AFM DESIGN
- MAGNETIC FORCE MICROSCOPE
- ATOMIC FORCE MICROSCOPE
- SCANNING HALL PROBE MICROSCOPE
- EFM, PFM, SSRM, STM, ETC...

CRYOGEN FREE CRYOSTAT

- VIBRATION-FREE DESIGN
- 100% DRY SYSTEM
- CLOSED-CYCLE
- 2.6K-300K
- UP TO 16 TESLA
- LOW OPERATING COSTS





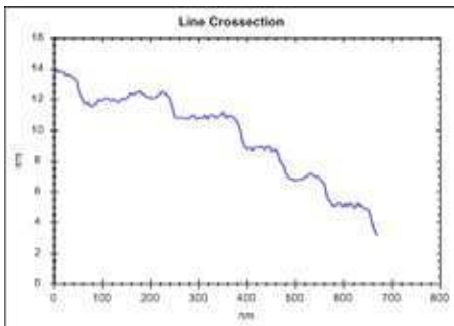
System Specifications

Imaging Modes	: MFM, Conductive AFM, EFM, STM, Contact/Semiconduct/Non-Contact mode AFM using digital PLL		
Scan Size	: Large Area Scan Head 150 x 150 μm @ 300 K 36 x 36 μm @ 77 K 18 x 18 μm @ 4.2 K	: Standart Scan Head 52 x 52 μm @ 300K 14 x 14 μm @ 77 K 6 x 6 μm @ 4.2 K	: Small Area Scan Head 8 x 8 μm @ 300 K 3.5 x 3.5 μm @ 77 K 1.5 x 1.5 μm @ 4.2 K
Z Range	: 7.0 μm @ 300 K 1.8 μm @ 77 K 0.8 μm @ 4.2 K	: 4.8 μm @ 300 K 1.2 μm @ 77 K 0.5 μm @ 4.2 K	: 2.4 μm @ 300 K 0.6 μm @ 77K 0.25 μm @ 4.2K
Head Dimensions	: 23.6 mm OD x 125 mm or 25.4 mm OD x 100 mm		
Sample Approach	: Stick-slip type; 10 mm Z, \varnothing 3 mm XY range with 50 - 800 nm step size		
Fine Sample Positioning	: Capacitive encoder with 2 μm resolution		
Sample Size	: 15 x 15 x 5 mm maximum		
Sample Holder	: 5 pins connections for experiments: One bias voltage, 4 spares		
Temperature Range	: 1K-300 K (Limited by the system)		
Magnetic Field	: >16 T		
Operation	: Vacuum or exchange gas environment		

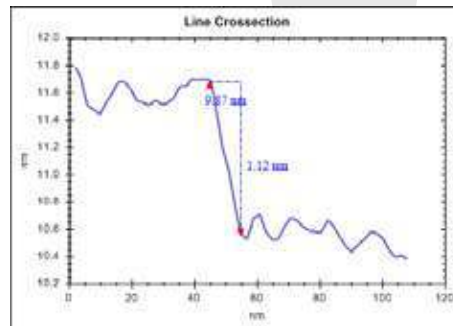
Software upgrades are free for lifetime

Note: Specifications are subject to change without notice.

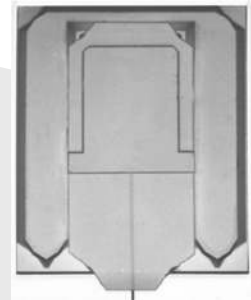
Cross-section of the single mica steps



Cross-section of the double mica step



Alignment free cantilevers from NanoSensors®



LT-AFM Image of the etched mica surface